

PXY & PZ D12

Compact Piezo Scanner



Motion range up to 200 µm



Accurate parallel motion due to flexure guidance system



High resonant frequency up to 760 Hz



Easily combined with other piezo electrical systems

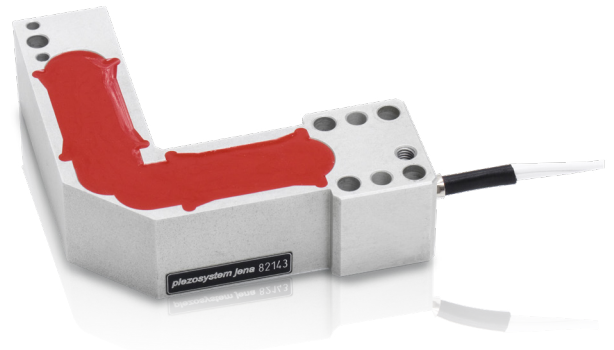


Image: PXY 80 D12

Due to solid state flexure and parallelogram construction, the PZ 38 nano-positioning stage can travel without any mechanical play in the X and Z axes, and provide a much higher resolution than is possible with mechanical or electromechanical systems.

This PZ piezo stage can be easily combined with XY-elements of the XYZ series or with tilting piezo-electric modules of the PSH series to allow positioning with all degrees of freedom. Additionally this Z-axis nano-positioning stage can run dynamically.

The PZ 38 can optionally be equipped with measurement systems (strain gauge or capacitive sensors) that compensate for hysteresis.

Variants:

- PXY 40 D12
- PXY 80 D12
- PXY 200 D12
- PZ 8 D12
- PZ 20 D12

Recommended Controller:

NV 40/3



E-101-20

Applications

- Optics and fiber positioning
- Scanning systems
- Laser optics
- Micro-manipulation

PXY & PZ D12

Technical Data

	Unit	PXY 40 D12	PXY 80 D12	PXY 200 D12	PZ 8 D12	PZ 20 D12
Part no	-	S-605-37	S-605-10	S-605-20	S-605-60	S-605-63
Axes	-	x, y	x, y	x, y	z	z
Motion open-loop ($\pm 10\%$)*	μm	40	80	200	8	20
Capacitance ($\pm 20\%$ **)	μF	0.7	1.7	2.6	0.7	0.7
Resolution open-loop*	nm	0.08	0.16	0.4	0.02	0.04
Resonant frequency	x, y	1100 / 1300	900 / 1200	400 / 600	-	-
	z					
Stiffness (per axis)	N/ μm	1.5 / 1.8	0.8 / 0.55	0.3 / 0.2	4.7	3.3
Max. push forces (per axis)	N	60/72	64/44	60/40	37.6	66
Max. pull forces (per axis)	N	6/7	6/4	6/4	4	7
Voltage range	V	-20 ... +130				
Connector	Voltage/sensor	LEMO				
Cable length	m	1	1	1	1	1
Material	-	stainless steel				
Dimensions (l/w/h)	mm	54 x 53.5 x 20	54 x 53.5 x 16	57.5 x 64 x 16	21 x 26 x 15	20.5 x 26 x 15
Weight	g	90	90	160	13	16

series PXY D12 + z-axis extension PZ D12 with SG feedback sensor	Unit	-	PXY 80 D12	PXY 200 D12	PZ 8 D12	PZ 20 D12
Part no	-	-	S-605-14	S-605-21	S-605-61	S-605-64
Motion open-loop ($\pm 10\%$)* per axis	μm	-	80	200	8	20
Motion closed-loop ($\pm 0.2\%$)* per axis	μm	-	65	160	6.4	16
Feedback sensors	-	-	strain gauge			
Resolution closed-loop*	nm	-	1.6	4	0.16	0.4
Typ. repeatability	nm	-	5	9	2	3
Max. push force (per axis)	N	-	64/44	60/40	37.6	66
Max. pull force (per axis)	N	-	6/4	6/4	4	7
Connector	Voltage/sensor	-	LEMO/ODU (analog) / D-Sub (digital)			
Cable length	m	-	2	2	2	2
Weight	g	-	90	160	30	45

series PXY D12 + z-axis extension PZ D12 with CAP feedback sensor	Unit	-	PXY 80 D12	PXY 200 D12
Part no	-	-	S-605-16	S-605-26
Motion open-loop ($\pm 10\%$) per axis	μm	-	80	200
Motion closed-loop* ($\pm 0.2\%$) per axis	μm	-	65	160
Feedback sensors	-	-	capacitive sensor	
Resolution closed-loop*	nm	-	1	
Typ. repeatability	nm	-	5	6
Max. push force (per axis)	N	-	64/44	60/40
Max. pull force (per axis)	N	-	6/4	6/4
Connector	Voltage/sensor	-	LEMO/ODU (analog) / D-Sub (digital)	
Cable length	m	-	2	2
Dimensions (l x w x h)	mm	-	64 x 63.5 x 22	75.5 x 69 x 27
Weight	g	-	155	225

Rights reserved to change specifications as progress occurs without notice!

* typical value measured with NV 40/3 amplifier (closed loop: NV 40/3 CLE amplifier) and the resolution is only limited by the noise of the power amplifier and metrology

** typical value for small electrical field strength